

Docket No.: HU-2130
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Roy G. GORDON et al. Confirmation No.: 7410
Application No.: 10/534,687 Art Unit: 2812
Filed: May 12, 2005 Examiner: Not Yet Assigned
Title: ATOMIC LAYER DEPOSITION USING METAL AMIDINATES

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT (IDS)

Dear Sir:

This Supplemental Information Disclosure Statement is being filed prior to the mailing date of a first Office Action on the merits. No fee is required.

Applicants request that the Examiner initial and return a copy of the enclosed Form PTO SB-08 with the next communication.

Applicants believe no fee is due with this response. However, if a fee is due, please charge our Deposit Account No. 08-0219, under Order No. 0042697.00149US3 from which the undersigned is authorized to draw.

Respectfully submitted,

Dated: April 14, 2008

/Mary Rose Scozzafava, Reg. No. 36,268/
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